

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants: KOBAYASHI
Application No.: 10/563,302
Filed: 1/4/2006
Title: ELECTROSTATIC CHUCK FOR SUBSTRATE STAGE, ELECTRODE USED
FOR THE CHUCK, AND TREATING SYSTEM HAVING THE CHUCK AND
ELECTRODE
Art Unit: 2836 Exr.: T. MAI CONF. No.: 8395

AMENDMENT

MS: AMENDMENT
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

September 23, 2010

Sir:

In response to the Office Action dated June 23, 2010, please amend the
above-identified application as listed below and as set forth on the following pages:

Amendments to the Claims;

Remarks are included following the amendments.